

#28
Amite
J. W. H.
1-1504

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Applicants:

Date: October 23, 2003

Beaman et al.

Group Art Unit: 2829

Serial No.: 09/251,988

Examiner: J. M. Hollington

Filed: February 17, 1999

Docket No.: YO999-088

For: **STRUCTURAL DESIGN AND PROCESSES TO CONTROL PROBE
POSITION ACCURACY IN A WAFER TEST PROBE ASSEMBLY**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**FAX RECEIVED****OCT 23 2003****AMENDMENT****PETITIONS OFFICE**

In response to Office Action dated July 10, 2003, please consider the following:

RECEIVED**OCT 29 2003****OFFICE OF PETITIONS**